



#14/c

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	)	<u>PATENT APPLICATION</u>
	)	
Inventor: Wei Pan, Yoshi Ono, David R. Evans, and Sheng Teng Hsu	)	April 29, 2003
	)	
Serial No.: 09/819,296	)	ATTORNEY DOCKET
	)	No. SLA0515
	)	
Filed: March 27, 2001	)	Group Art Unit: 2811
	)	
Title: MULTI-LAYERED BARRIER	)	Examiner: Hung K. Vu
METAL THIN FILMS FOR	)	
Cu INTERCONNECT BY	)	
ALCVD	)	
	)	
	)	

REQUEST FOR CONTINUED EXAMINATION AND  
RESPONSE UNDER 37 C.F.R. § 1.114

Hon. Commissioner for Patents  
Washington, D.C. 20231

Sir:

This amendment and request for continued examination responds to a final Office Action dated December 31, 2002 in the above-identified application.

---

Please amend the application as follows:

IN THE CLAIMS:

Please amend claims 8, 14, and 21 by rewriting the claims to the following: